Vertical electropolishing of niobium nine-cell cavity with a cavity flipping system for uniform removal **©KEK**

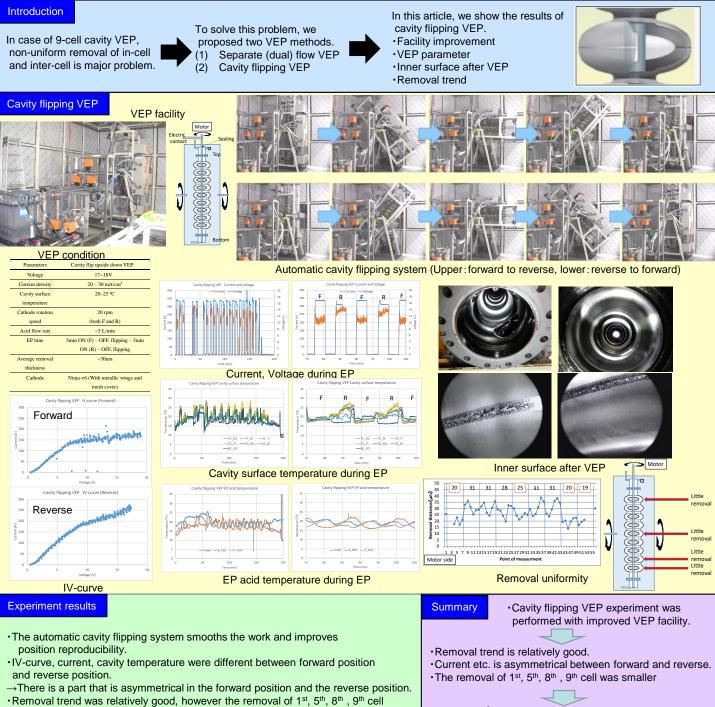


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TUP027

Marui Galvanizing Co., Ltd. has been developing vertical electropolishing (VEP) technology for single and nine-cell niobium superconducting radio frequency cavities using a unique cathode namely Ninja cathode in collaboration with KEK. The VEP process usually results in nonuniform removal with a large asymmetry along the cavity length. In order to suppress the asymmetry in removal, we are making different approaches. Flipping of the cavity during the VEP process is one of the approaches applied so far. A unique VEP setup, which allows the flipping of a multi-cell cavity, has been developed as reported earlier. Here, we report the improvement in the setup with automation for cavity flipping. VEP experiments were conducted with the improved system. VEP parameters were studied and the VEP results including the removal trend are discussed in detail.



Improve system symmetry

VEP parameter optimization

was smaller than other cells.